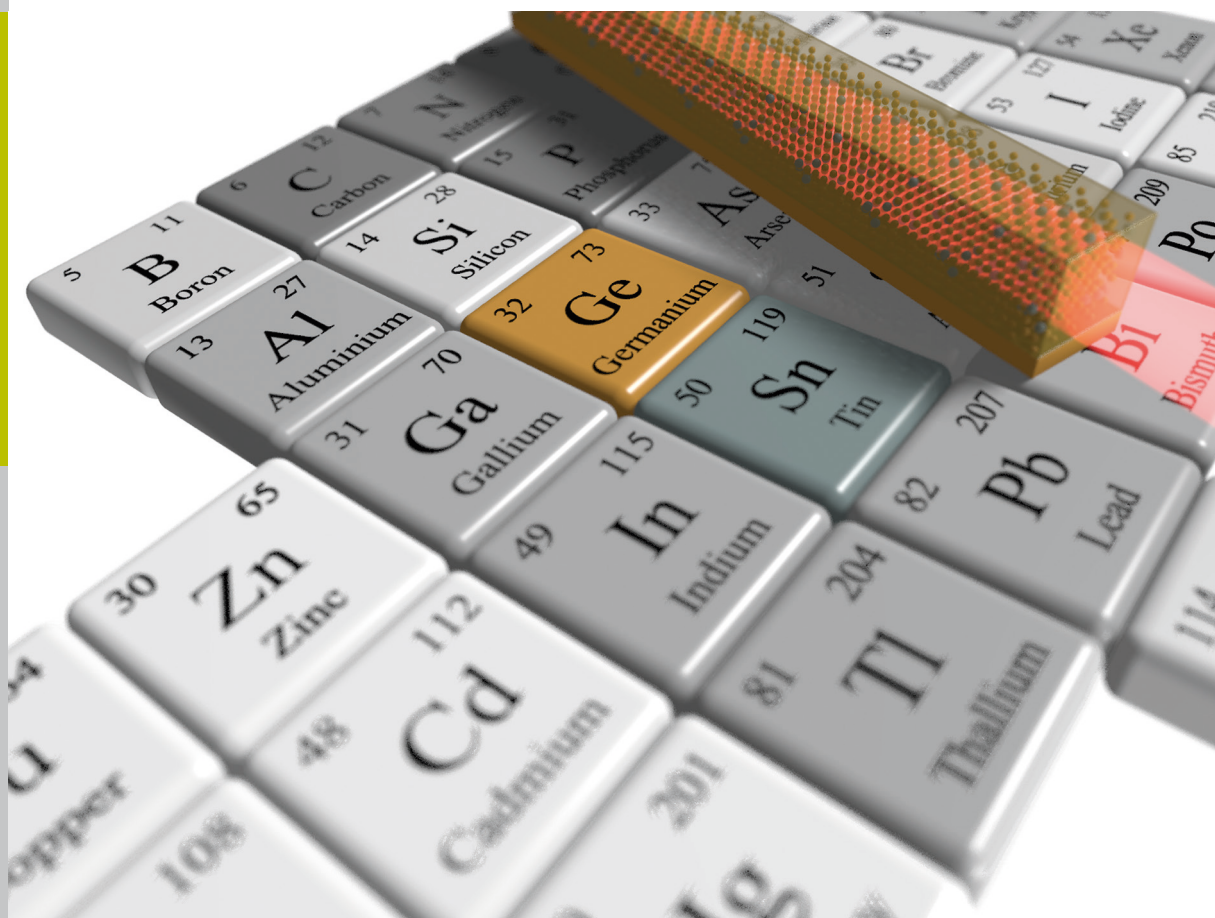


Group IV Epitaxy for Advanced Nano- and Optoelectronic Applications

Stephan Wirths



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